

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

/Robert Kunemund/

03/02/2008

IN THE MATTER OF:

ART UNIT: 1792

Jaehwan EUN, et al

EXAMINER: Kunemund, Robert M.

SERIAL NO.: 10/539,883

CONFIRMATION NO.: 1957

FILED: June 17, 2005

FOR: Method For Preparation of Ferroelectric Single Crystal Film Structure Using  
Deposition Method

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Arlington, VA 22313-1450

S I R:

This is in response to the outstanding Office Communication dated  
November 14, 2007. The Commissioner is authorized to charge any fees required in  
the prosecution of this application to Deposit Account No. 503814.

Please amend the present application as follows: